



501.41125X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. HIROI, et al  
Serial No.: 10/062,666  
Filed: February 5, 2002  
For: PATTERN INSPECTION METHOD AND  
SYSTEM THEREFOR  
Group: 2881  
Examiner: J. Berman

**SUPPLEMENTAL AMENDMENT AFTER FINAL REJECTION**

Mail Stop: Box AF Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 12, 2007

Sir:

The following supplemental amendments and remarks are respectfully submitted in connection with the above-identified application in response to the Office Action dated September 18, 2006, the Advisory Action dated January 30, 2007, and the telephone discussion with the Examiner. The amendments submitted are as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.